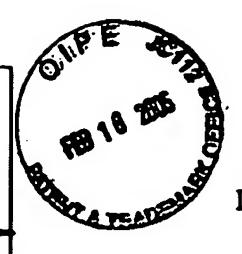
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as Express Mail, Airbill No. EV506674675US, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: February 18, 2005





Docket No.: 514802002600 Client reference: AD-0371US

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Mitsuyuki ASAKI et al.

Confirmation No.: 4476

Application No.: 10/664,440

Examiner: Johnnie L. Smith

Filed: September 18, 2003

Art Unit: 2881

For: PATTERN WIDTH MEASURING

APPARATUS, PATTERN WIDTH

MEASURING METHOD, AND ELECTRON

**BEAM EXPOSURE APPARATUS** 

RCE processed 4/21/05 Amw

## **AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

## INTRODUCTORY COMMENTS

In response to the Office Action dated November 18, 2004, for which a response is due on February 18, 2005, please amend the above-identified U.S. patent application as follows:

3/2/1/5

LA-772941